

Tech-X Corporation will hold a VORPAL User Group Meeting (VUGM) during the upcoming [APS Division of Plasma Physics meeting](#), being held at the Hyatt Regency Chicago on the Riverwalk from Nov 8 – 12. The VUGM will be held on Wednesday, November 10, from 12:30PM – 2:00PM in Skyway 265.

Scheduled talks include:

VORPAL Overview, Ed Kase, Tech-X Corporation

Numerical simulation of plasma sputtering system with VORPAL, Chuandong (Sean) Zhou, Ph.D., Tech-X Corporation

Simulations of a Smith-Purcell free-electron laser using VORPAL, Chris Prokop, Northern Illinois University

Simulations of plasma formation and sustainment in a microwave plasma source, Ron Bravenec, Ph.D., Fourth State Research and Tokyo Electron America

VORPAL Composer Preview, David Smithe, Ph.D., Tech-X Corporation